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FIG. 1

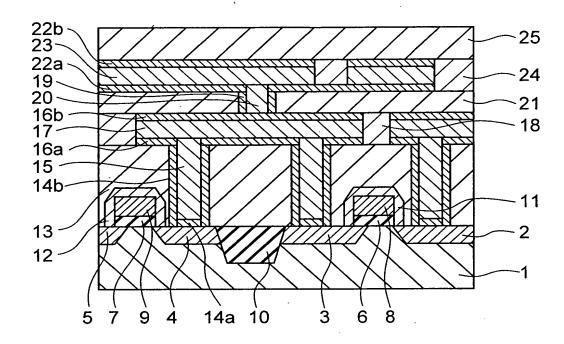
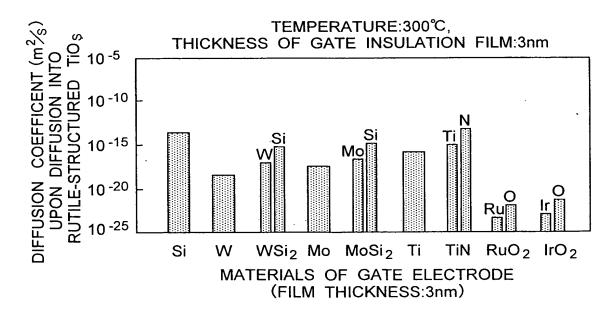


FIG. 2



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conductor Device and Method of Manufact Atty Dock t No. 16869S-033100 Sheet 2 of 6



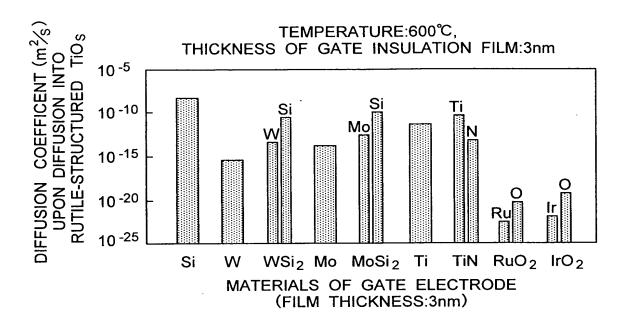
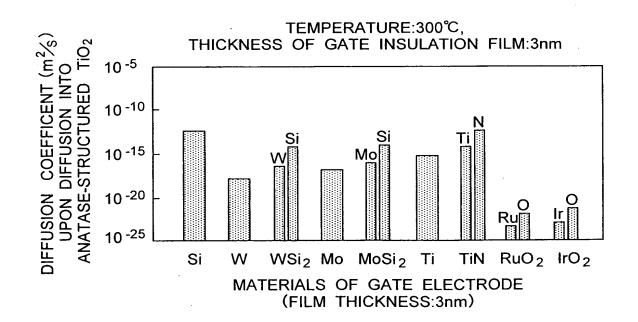


FIG. 4



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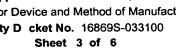


FIG. 5

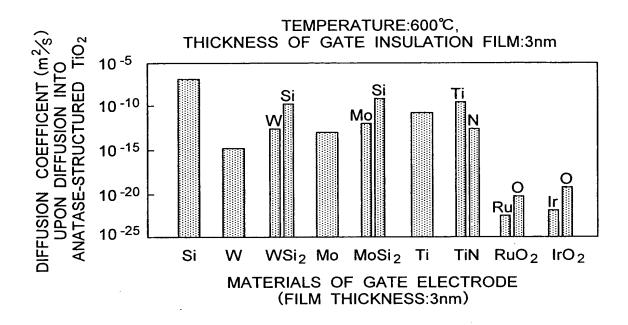
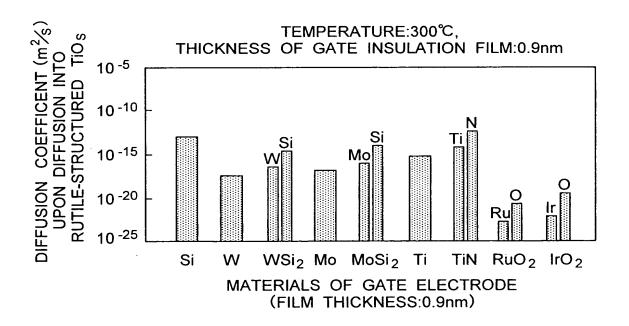


FIG. 6



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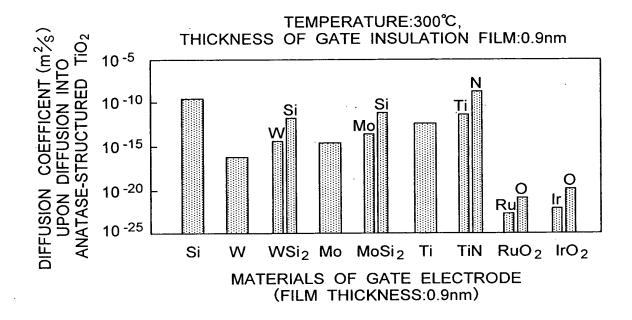
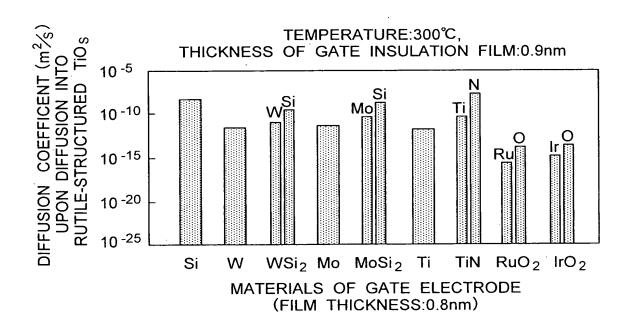


FIG. 8



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FIG. 9

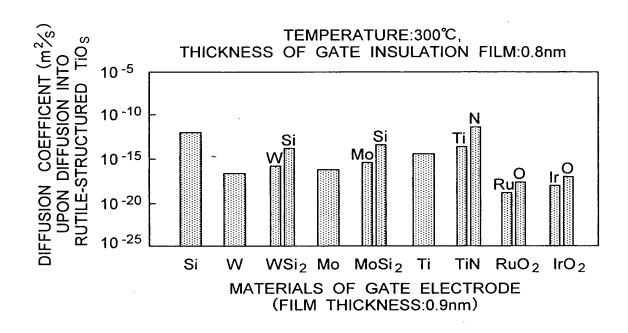
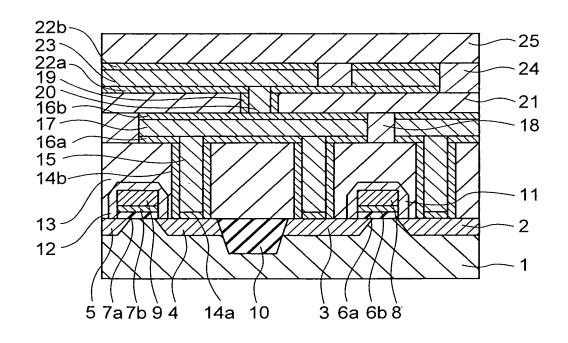


FIG. 10



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FIG. 11

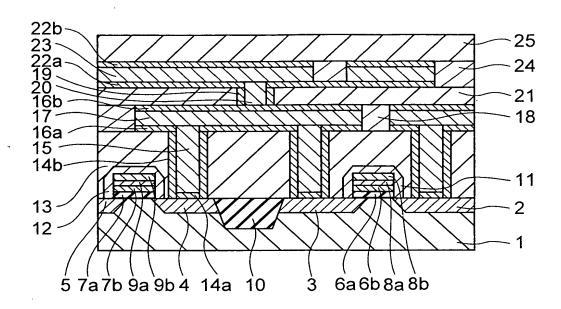


FIG. 12

